

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application )  
of U.S. Patent No. 6,329,275 )  
Issue Date: December 11, 2001 ) Group Art Unit: Unassigned  
First Named Inventor: Takashi Ishigami ) Examiner: Unassigned  
Application No.: Unassigned )  
Reissue Filing Date: December 10, 2003 )  
For: INTERCONNECTOR LINE OF THIN )  
FILM, SPUTTER TARGET FOR )  
FORMING THE WIRING FILM AND )  
ELECTRONIC COMPONENT USING )  
THE SAME )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CLAIM FOR FOREIGN PRIORITY**

Sir:

Under the provisions of Section 119 of 35 U.S.C., Applicants hereby claim the benefit of the filing date of Japanese Application Number 7-264472, filed October 15, 1995, for the above identified United States Reissue Application.

A certified copy of the priority application was filed during prosecution of the application that matured into U.S. Patent No. 6,329,275.

Respectfully submitted,

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Dated: December 10, 2003

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